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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IPA-006

Applicant : Akira Nakashima et al.
Title : METHOD OF FORMING AMORPHOUS SILICA-BASED COATING FILM
WITH LOW DIELECTRIC CONSTANT AND THUS OBTAINED
SILICA-BASED COATING FILM
Serial No. : 10/533,238
Filed : June 16, 2005
Group Art Unit : 2891
Examiner :

Hon. Commissioner of Patents
P.O. Box 1450, Alexandria, VA 22313-1450

January 19, 2007

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith are Information Disclosure Statement, European Search Report and five references.

Attached herewith is a credit card authorization form to cover the Surcharge for filing an IDS in the amount of \$180.00.

Respectfully submitted,
KANESAKA BERNER & PARTNERS

by Manabu Kanesaka
Manabu Kanesaka
Reg. No. 31,467
Agent for Applicants

1700 Diagonal Road, Suite 310
Alexandria, VA 22314,
(703) 519-9785
MAN/fs

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<div>INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)</div>				ATTY. DOCKET NO. IPA-006		U.S. PATENT APPLICATION NO. 10/533,238	
				APPLICANT Akira Nakashima et al.			
				FILING DATE 06/16/2005		GROUP 2891	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation Yes No	
	EP 0 226 208 A2	12/16/1986	Europe			X	
	EP 1 146 092 A2	04/09/2001	Europe			X	
	EP 1 142 832 A1	04/04/2001	Europe			X	
	EP 1 197 999 A1	12/15/2000	Europe			X	
	JP 2002-030249	01/31/2002	Japan			X	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.